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TITLE: SURFACE ACOUSTIC WAVE DEVICE AND ITS FREQUENCY

CHARACTERISTIC ADJUSTMENT METHOD

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ABSTRACT:

PURPOSE: To set the center frequency of a surface acoustic wave device to a desired frequency.

CONSTITUTION: An insulating film 20 and a $\underline{\text{ferromagnetic}}$ thin film 21 are

formed on a interdigital transducer IDT 15 on a <u>piezoelectric</u> substrate 11.

The $\underline{\text{piezoelectric}}$ substrate 11 is mounted on, e.g. a $\underline{\text{ferromagnetic}}$ stem and a

static magnetic field is applied to the <u>piezoelectric</u> substrate 11 in the

vertical direction. The $\underline{\text{ferromagnetic}}$ thin film 21 and the stem are magnetized

permanently by a static magnetic field and the surface pressure of the $% \left(1\right) =\left(1\right) +\left(1\right) +\left($

 $\underline{\text{piezoelectric}}$ substrate 11 is increased by the magnetic attractive force.

Since the film 21 and the stem are magnetized permanently, the

magnetic

attractive force is left between the $\underline{\text{ferromagnetic}}$ thin film 21 and the stem

even when they are released from the static magnetic field and the surface $% \left(1\right) =\left(1\right) +\left(1\right)$

pressure of the $\underline{\text{piezoelectric}}$ substrate 11 is adjusted constant at all times.

The propagation speed of the $\underline{\text{surface acoustic wave}}$ is changed by the increase

in the surface pressure to obtain a desired center frequency.

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